

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Martin Hausner
Serial No.: 10/524,525
Filed: August 18, 2005
Confirmation No.: 1134
Group Art Unit: 1792
Examiner: Ahmed, Shamim
Title: **METHOD FOR SELECTIVELY REMOVING MATERIAL FROM
THE SURFACE OF A SUBSTRATE, MASKING MATERIAL
FOR A WAFER, AND WAFER WITH MASKING MATERIAL**
Attorney Docket No.: BEET-09

Cincinnati, OH

January 28, 2008

PETITION FOR ONE (1) MONTH EXTENSION OF TIME

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.136(a), Applicant respectfully petitions for an extension of time of one (1) month from the original response date of September 26, 2007 for responding to the outstanding Office Action in the above-identified patent application. With the extension of time, the period for response now extends up to and includes January 26, 2008. Please see the electronic fee calculation sheet for the \$120.00 one month extension fee.

If any other charges or credits are necessary to complete this communication, please apply them to Deposit Account No. 23-3000.

Respectfully submitted,

/David H. Brinkman/
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Reg. No. 40,532

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